

SiW Electromagnetic Calorimeter

Testbeam results

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TILC09, Tsukuba, 18 April 2009

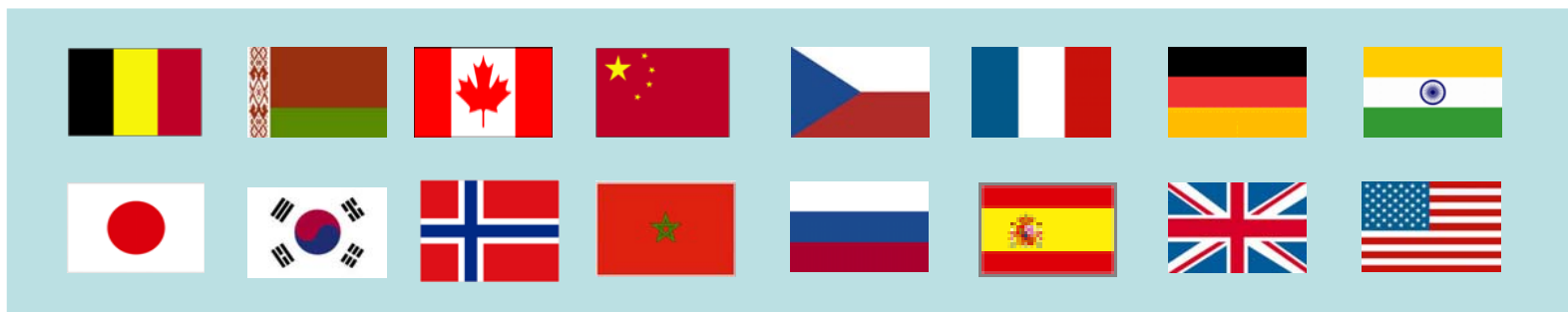
- The CALICE collaboration
- The Si-W prototype
- Testbeam results
 - Published results from 2006
 - Irradiation test
- Conclusion



The collaboration



Calorimeter R&D for

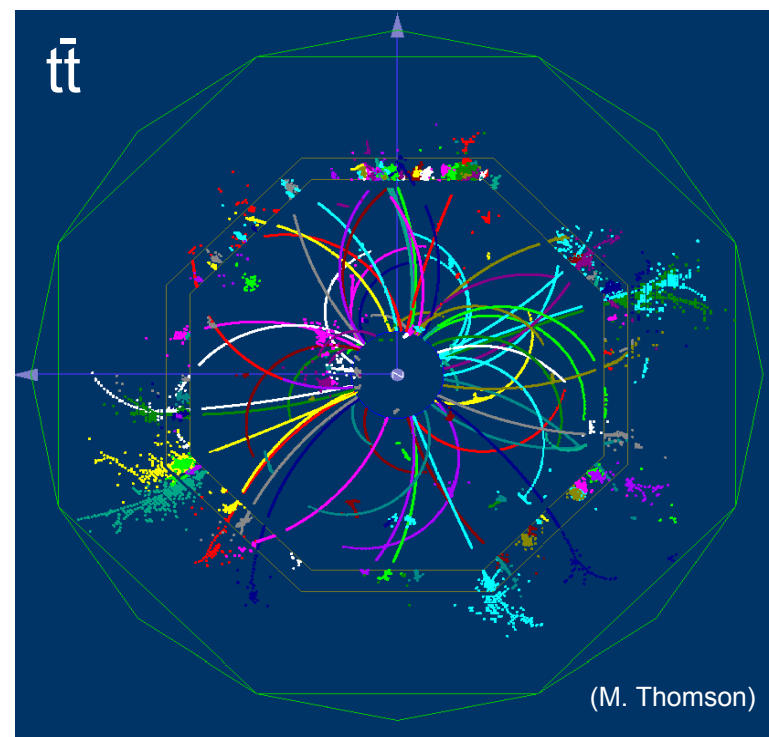
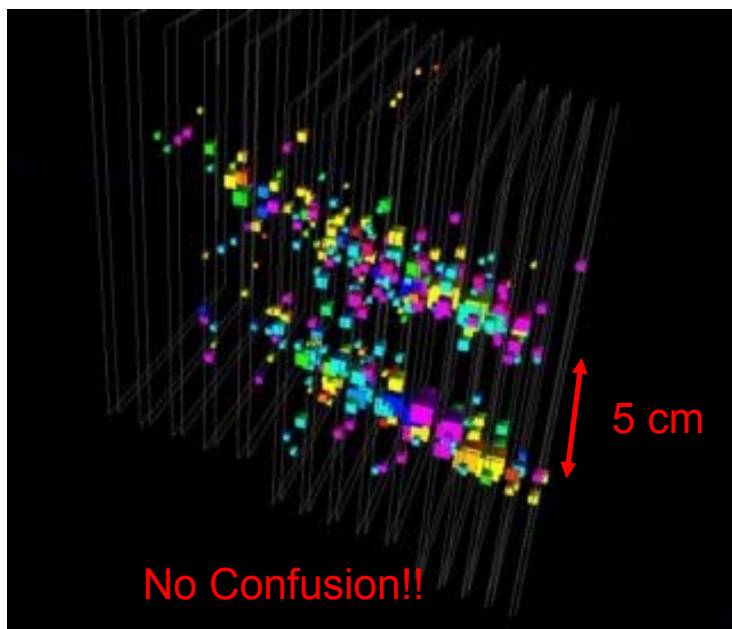


~297 physicists/engineers
53 Institutes
16 Countries
4 Continents

ILC goal:

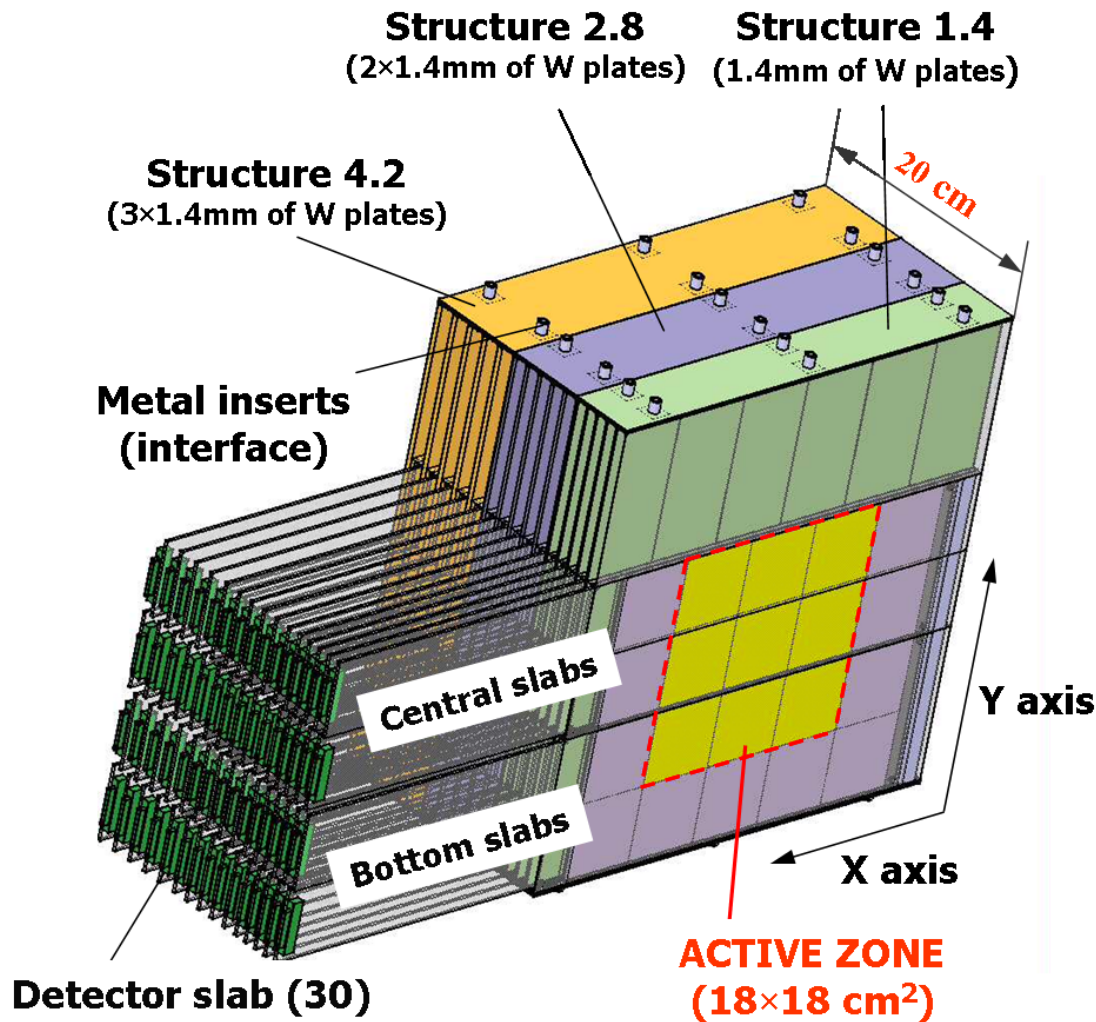
The physics at the International Linear Collider will require good jet energy resolution which can be obtained with **Particle Flow**.

In order to reconstruct every particle a high segmentation is needed.



CALICE goal:

Several prototype calorimeters have been built to establish the technologies. Data from testbeams will be used to tune clustering algorithms and validate existing MC models



Absorber material: **Tungsten**

Active material: **Silicon wafers**

1x1 cm² cells

6x6 cells in a wafer

3x3 wafers in a layer

30 layers of Tungsten:

- 10 x 1.4 mm (0.4 X_0)
- 10 x 2.8 mm (0.8 X_0)
- 10 x 4.2 mm (1.2 X_0)
- 24 X_0 total

9720 channels



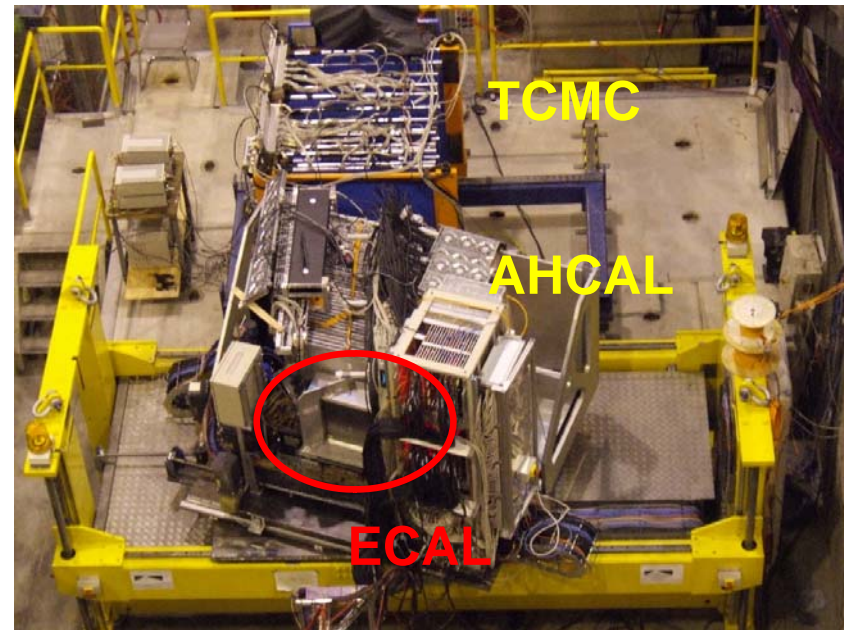
Testbeam program

ECAL Testbeam:

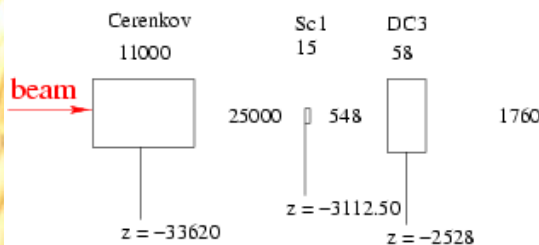
2006 at DESY and CERN (2/3 equipped)

2007 at CERN (almost fully equipped)

2008 at FNAL (fully equipped)



Slabs slit into
alveolas

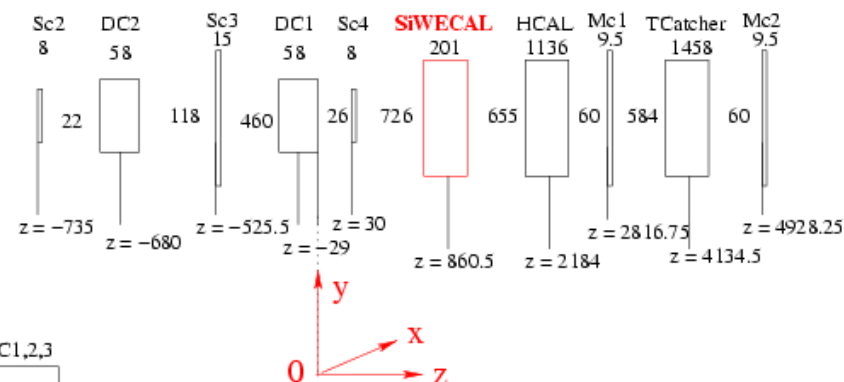


FRONT

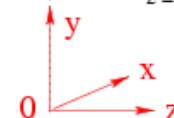
Sc1 is 30x30
Sc2 and Sc4 are 100x100
Sc3 is 200x200



CERN H6 area

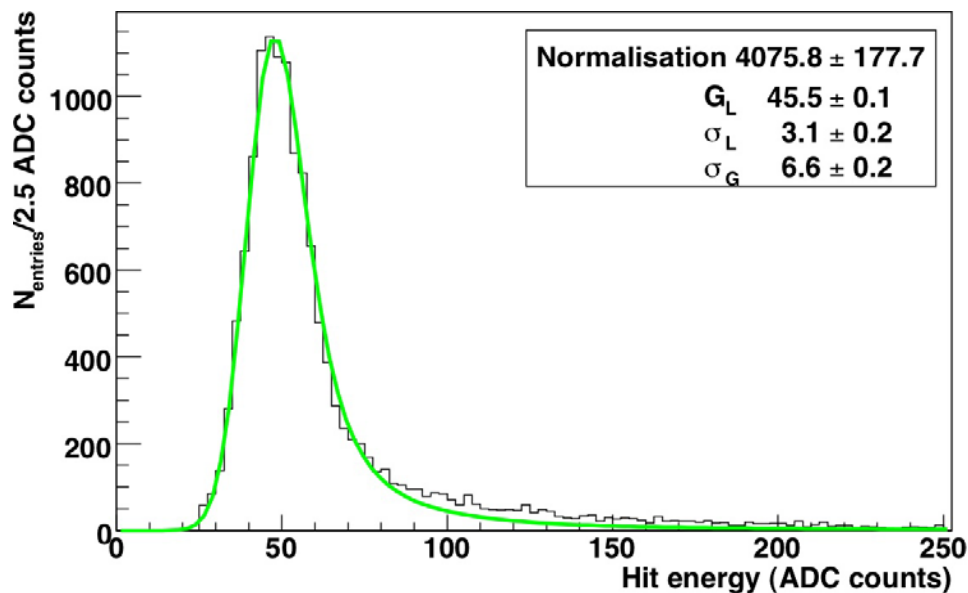


Mc1 and Mc2 are 1000x1000





Calibration



Calibration with muon beam

18 Mi. events

Only 0.14% of dead cells

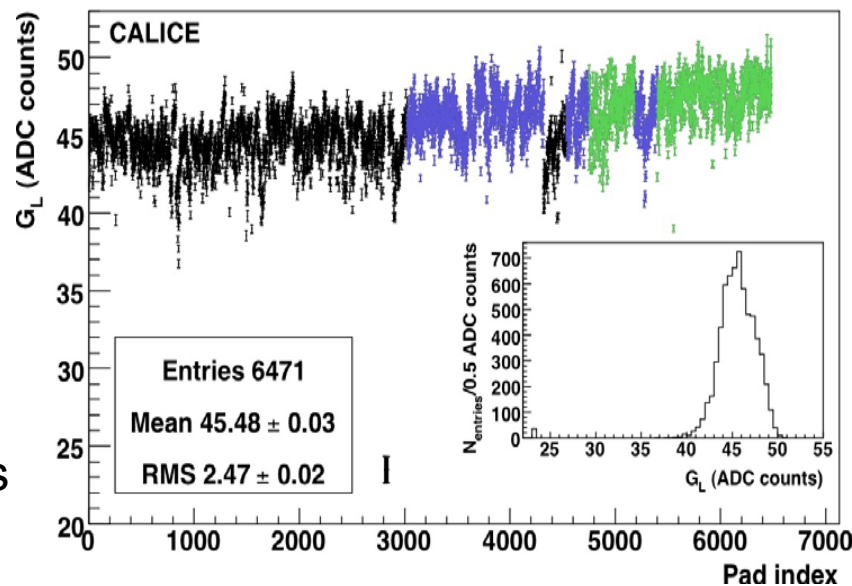
Uniform response

The differences can be associated with:

- Different manufacturers
- Different production

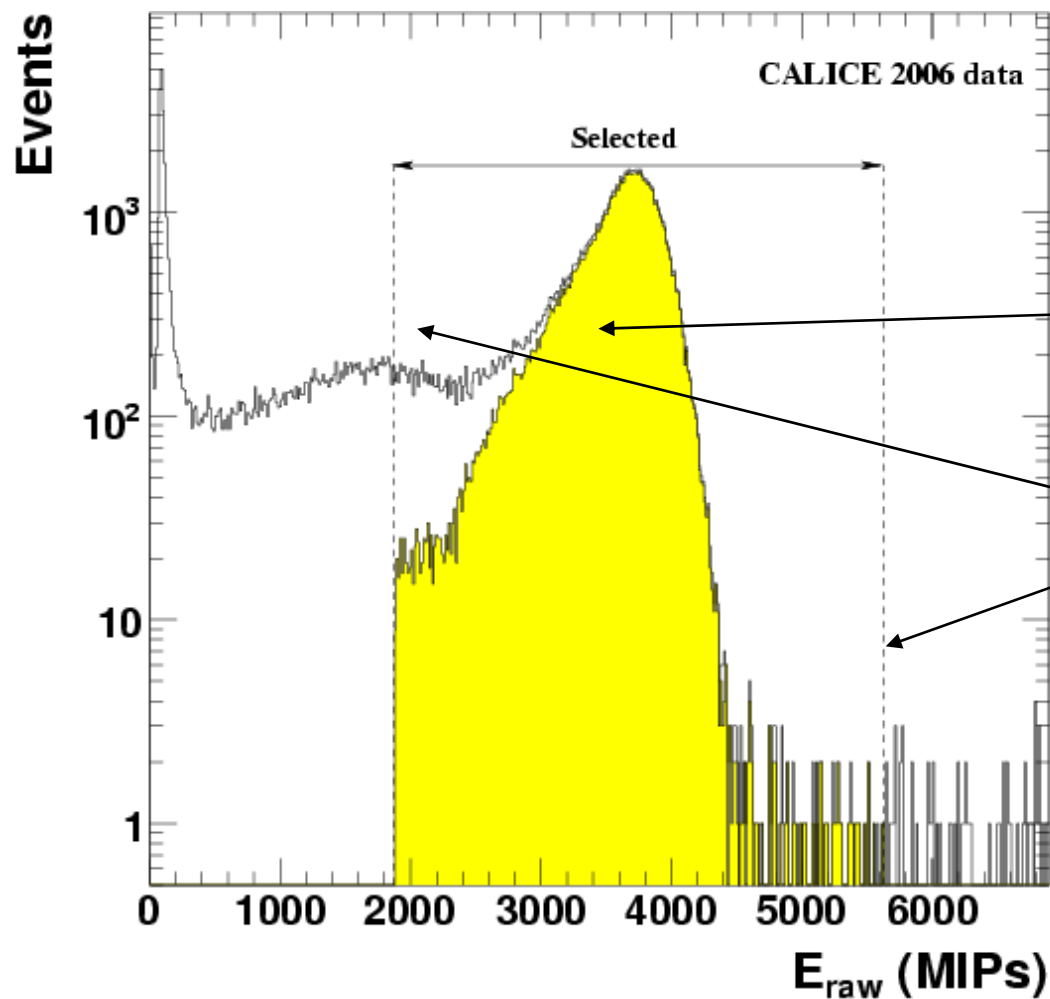
For final detector:

Experience to deal with different manufacturers
to produce the needed $\sim 3000 \text{ m}^2$





Electron selection



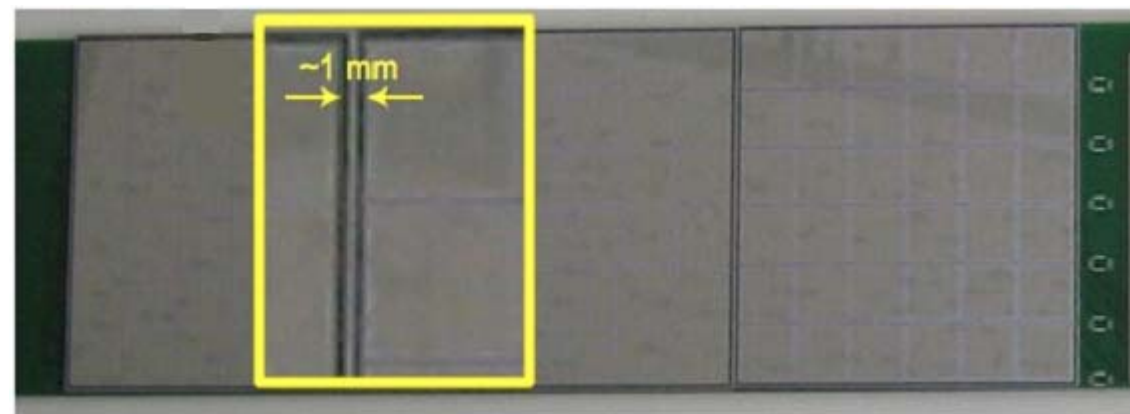
Cerenkov used to reject pions

Energy cut to remove:

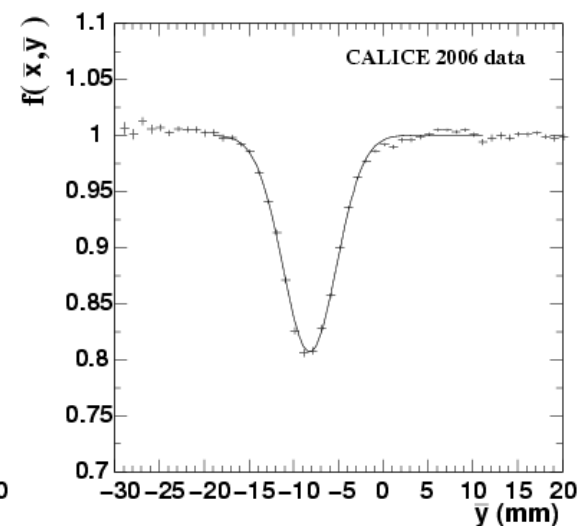
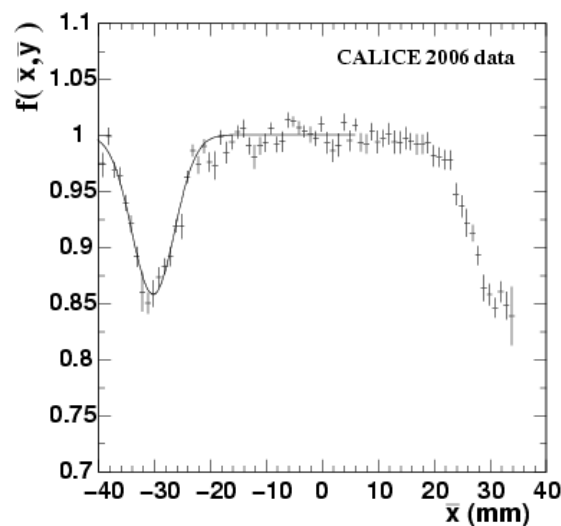
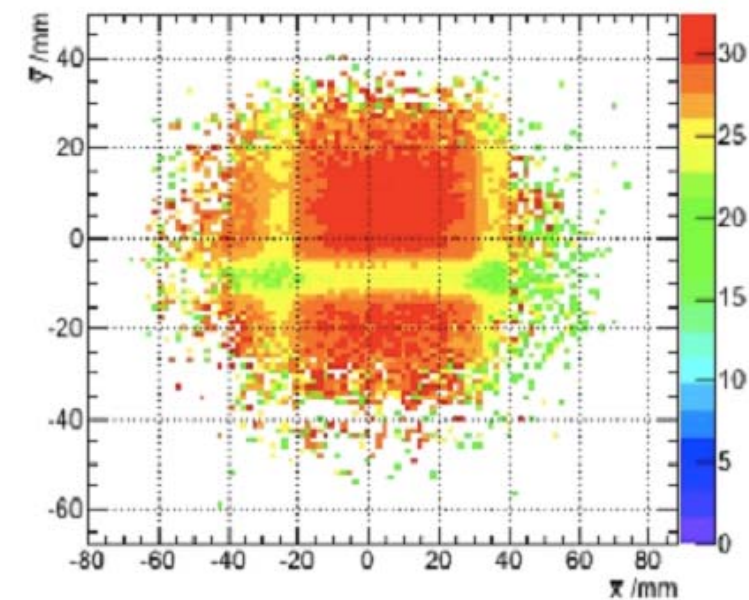
- pions
- double particle events



Detailed ECAL structure 1

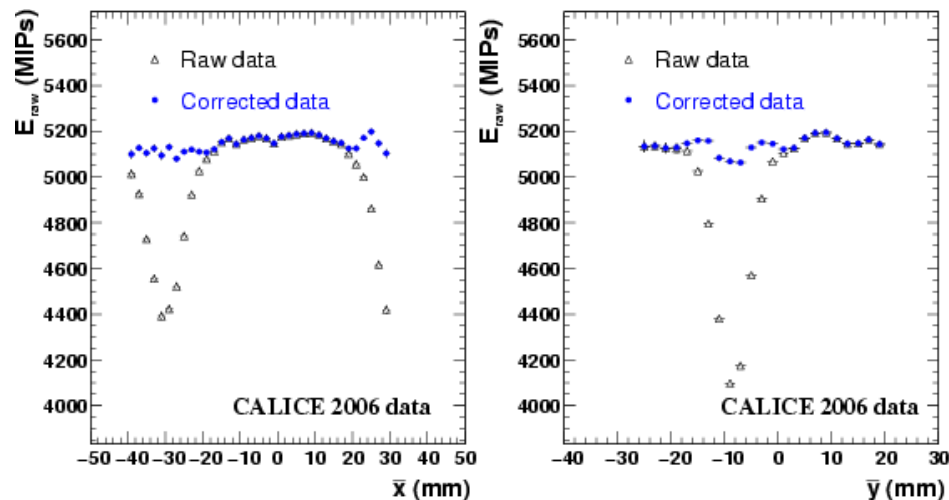


Wafers are separated by
~1 mm on both directions





Wafer correction

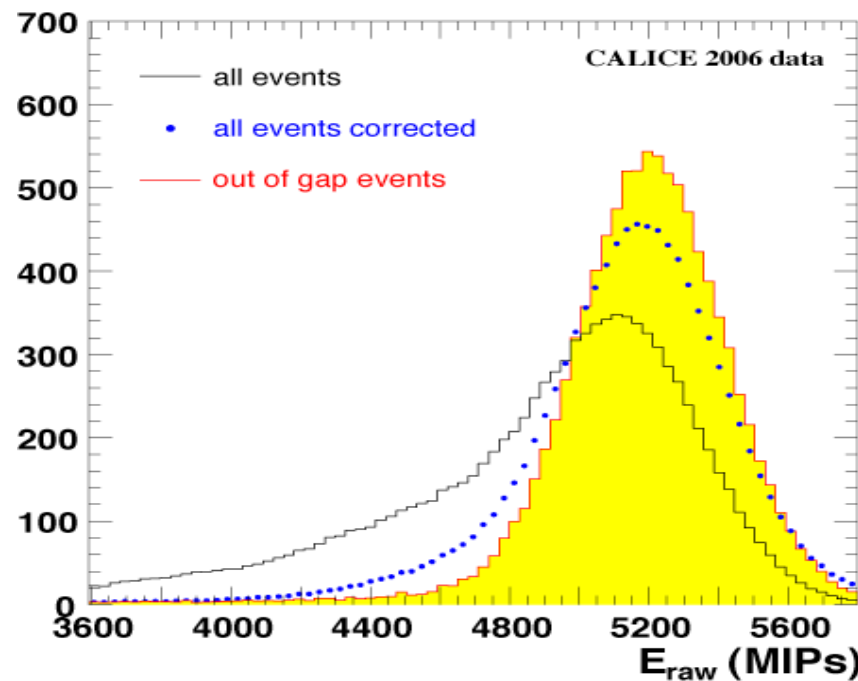


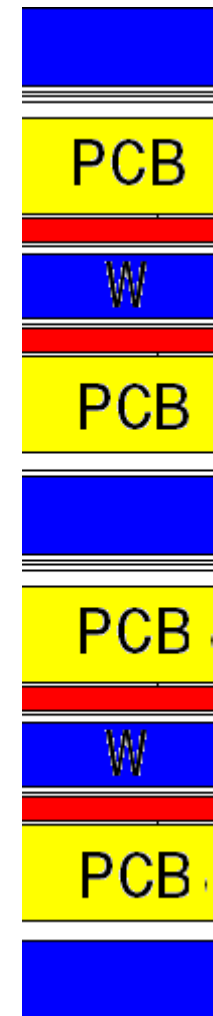
Gap region corrected using:

$$f(\bar{x}, \bar{y}) = \left(1 - a_x \exp\left(-\frac{(\bar{x} - x_{gap})^2}{2\sigma_x^2}\right) \right) \left(1 - a_y \exp\left(-\frac{(\bar{y} - y_{gap})^2}{2\sigma_y^2}\right) \right)$$

Energy loss not fully recovered

This result will drive the next generation of detector that will have smaller gaps

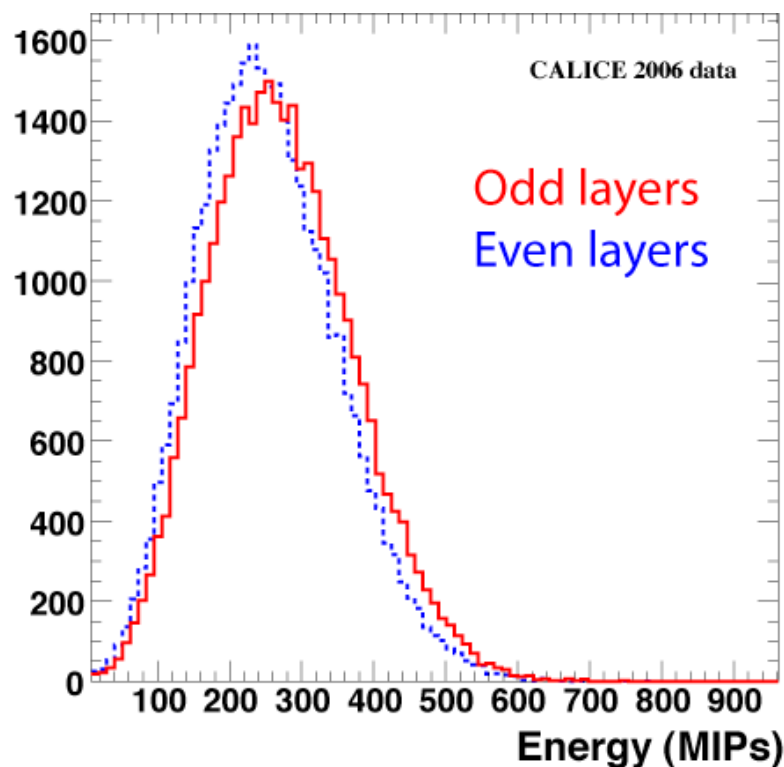




Odd and even layers have different material due to the PCBs



Material correction



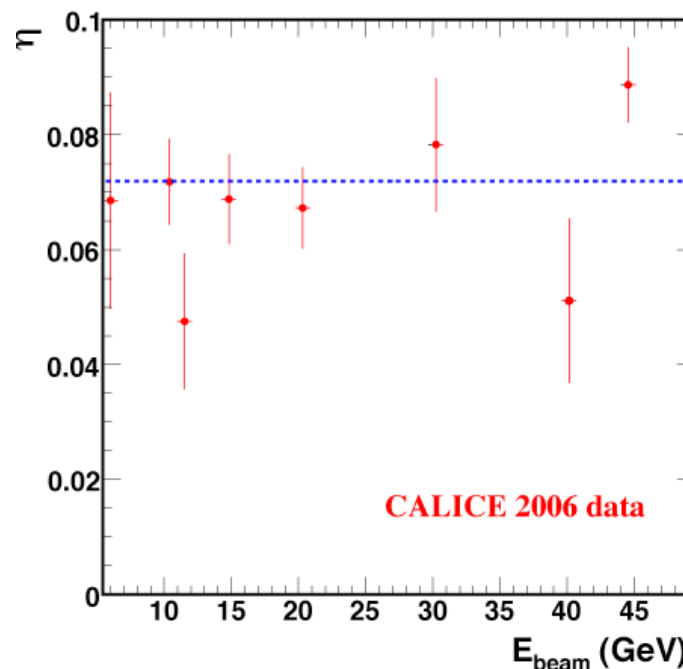
Sampling Fraction increases with calorimeter depth

$$E_{\text{rec}} = \sum_i w_i E_i \quad \text{with} \quad \begin{aligned} w_i &= 1 \text{ for } i=0,9 \\ w_i &= 2 \text{ for } i=10,19 \\ w_i &= 3 \text{ for } i=20,29 \end{aligned}$$

Different weights for odd and even layers:

Odd layers: $w = k + \eta$

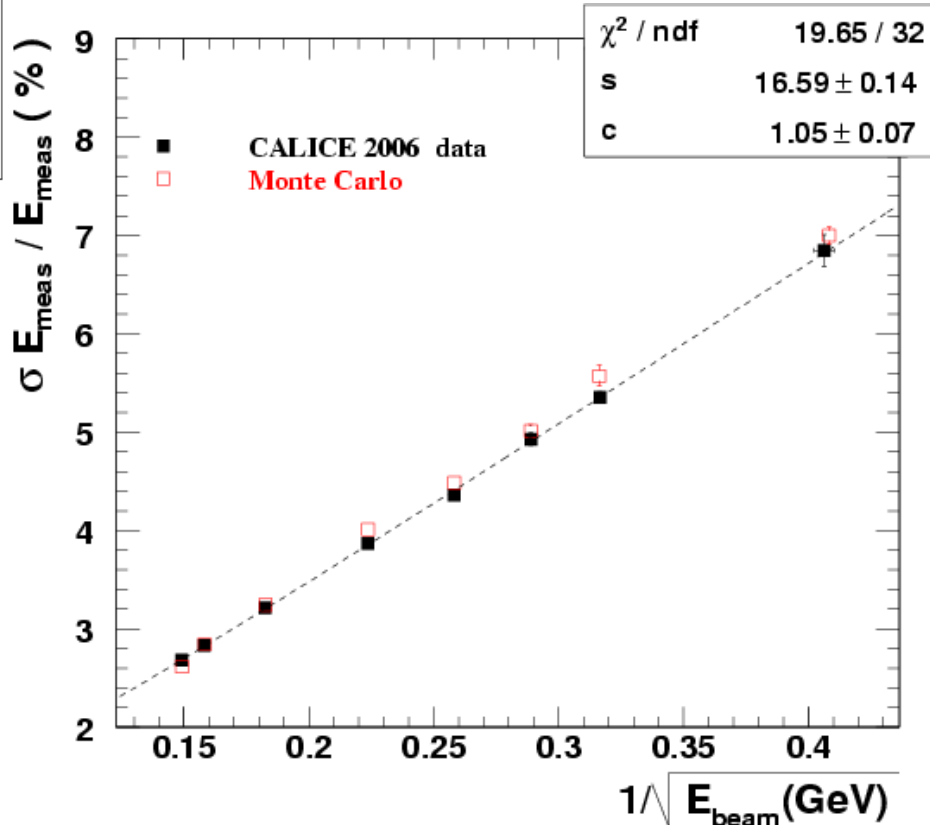
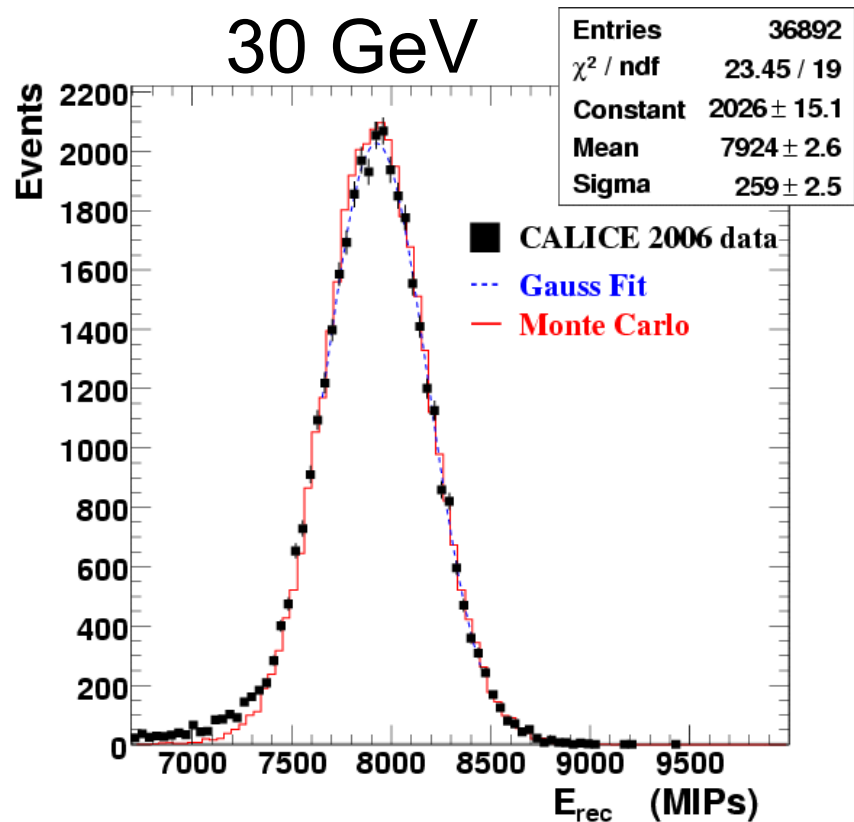
Even layers: $w = k$



$$\eta = (7.2 \pm 0.2 \pm 1.2)\%$$



Energy resolution



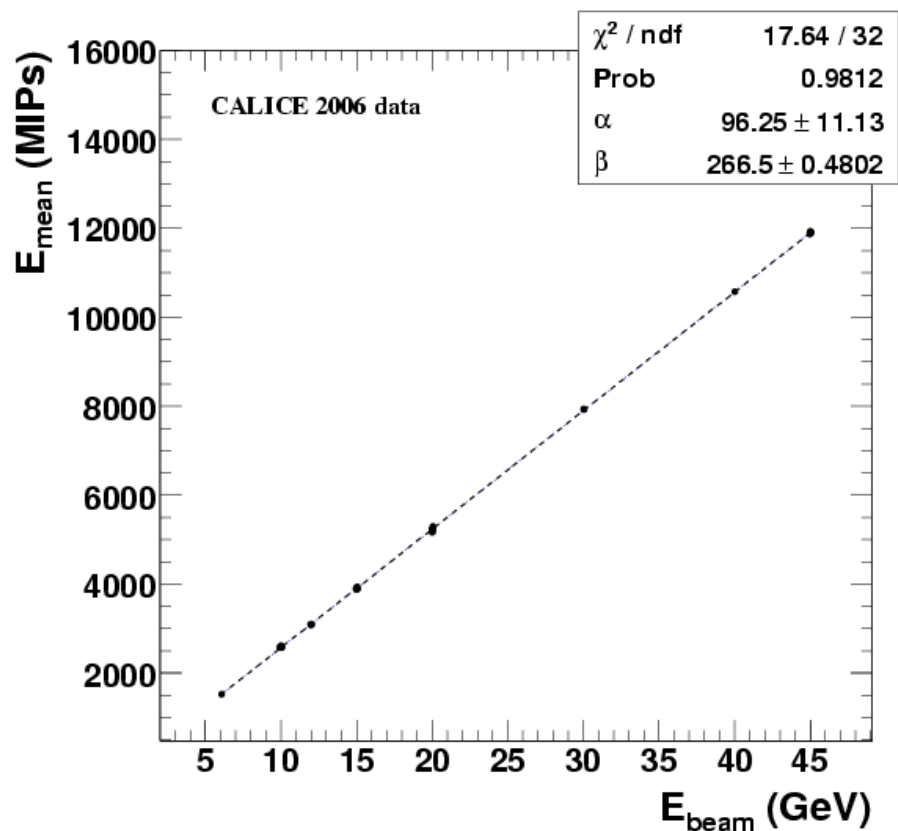
Good agreement between data and MC

Good energy resolution considering that the aim is to separate particles!

$$\frac{\sigma E_{Meas}}{E_{Meas}} = \left(\frac{16.6 \pm 0.1}{\sqrt{E(\text{GeV})}} \oplus (1.1 \pm 0.1) \right) \%$$

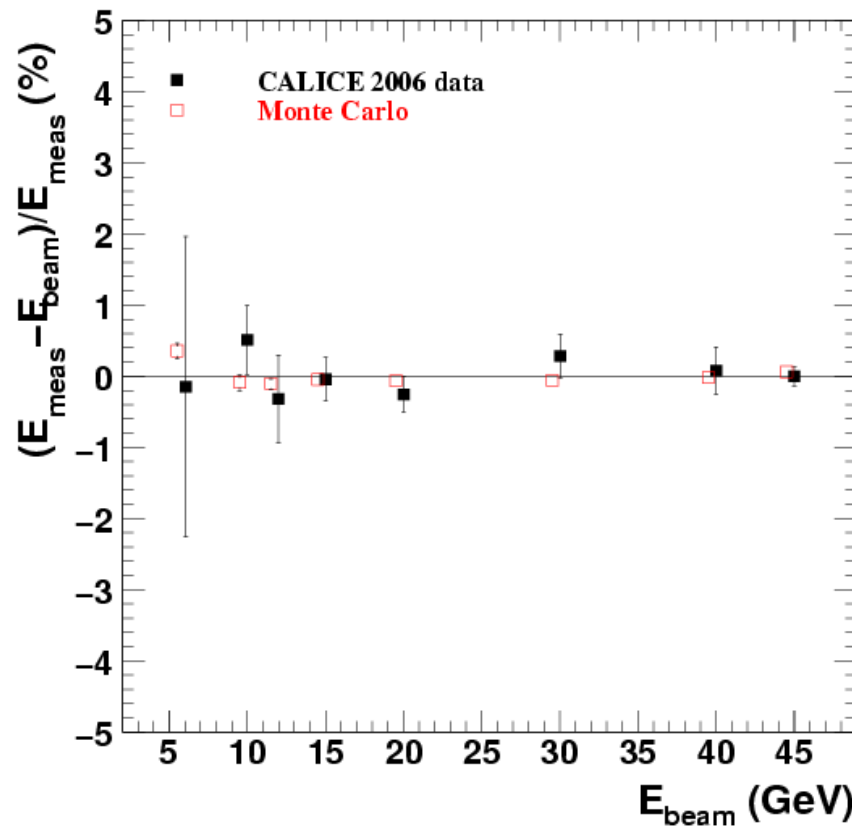


Linearity



Good linearity over a large energy range

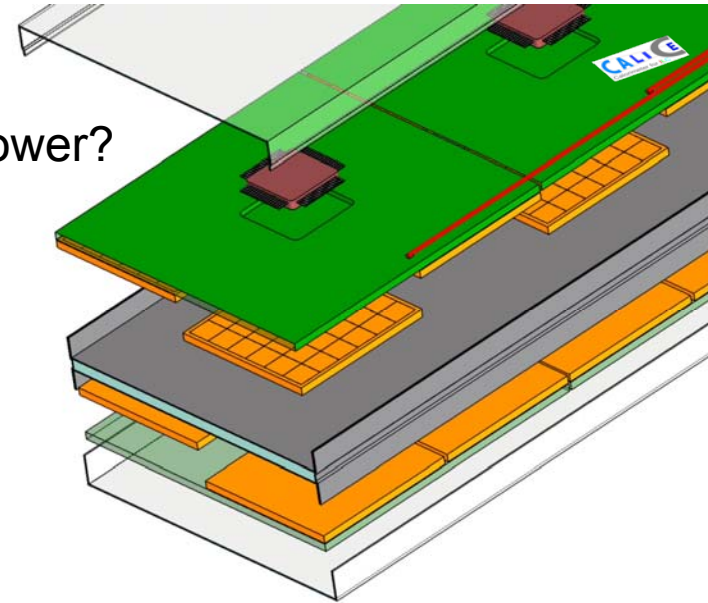
Good agreement between data and MC



Linear response within 1%

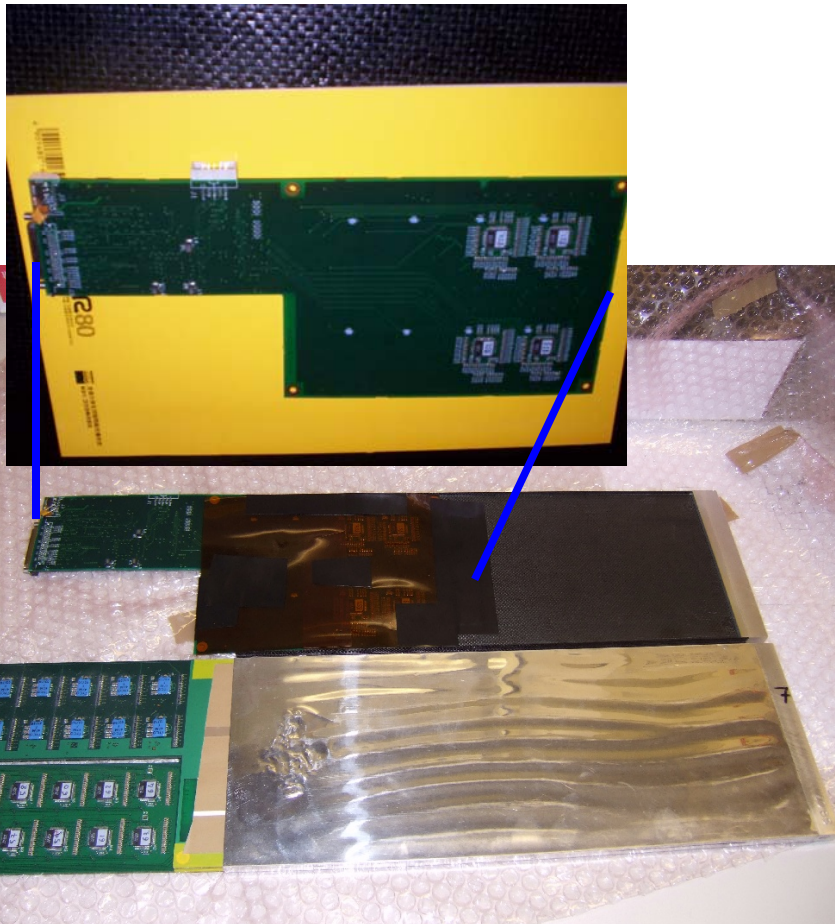
Final detector will have electronics embedded

Is any signal induced in the electronics by the EM shower?



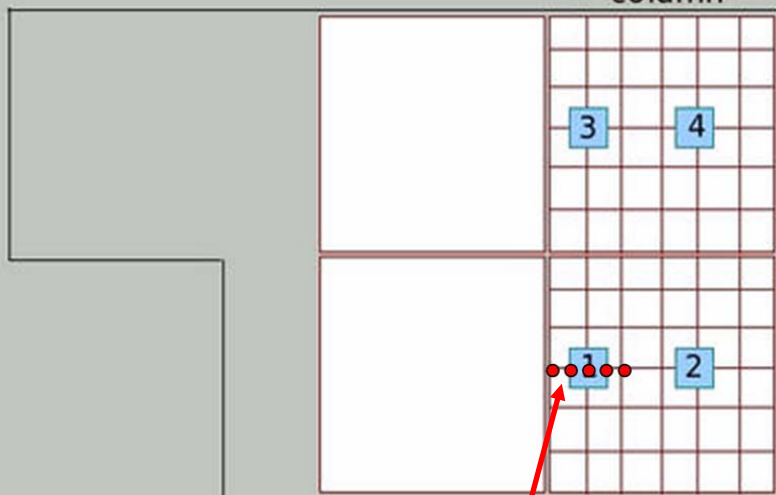
In 2007 a special slab was equipped with embedded chips (no Si wafers)

See poster session for further details!



Replacing Layer 12 (Slot 19, FE 2)

Left wafer column



- 1: (-8.33,0)
- 2: (-5.33,0)
- 3: (-8.33,6.2)
- 4: (-5.33,6.2)
- wrt ECAL (0,0)

Nominal position of chips

Sketch by M.Reinhard/F.Salvatore

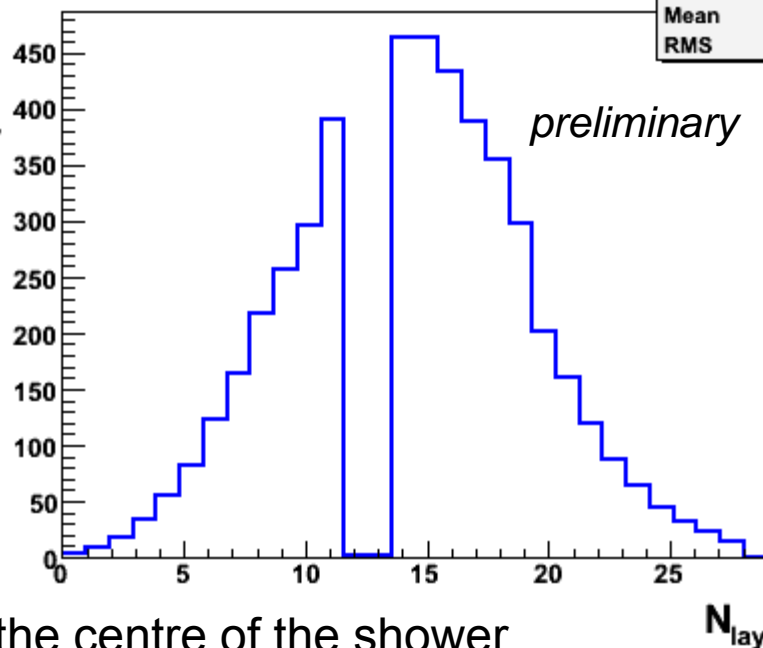
Scanning points (repeated for each chip)

$2.6 \cdot 10^6$ Events with 90 GeV Electrons

At least 70 K at each scanning point

Ecal: Energy Dep. per layer

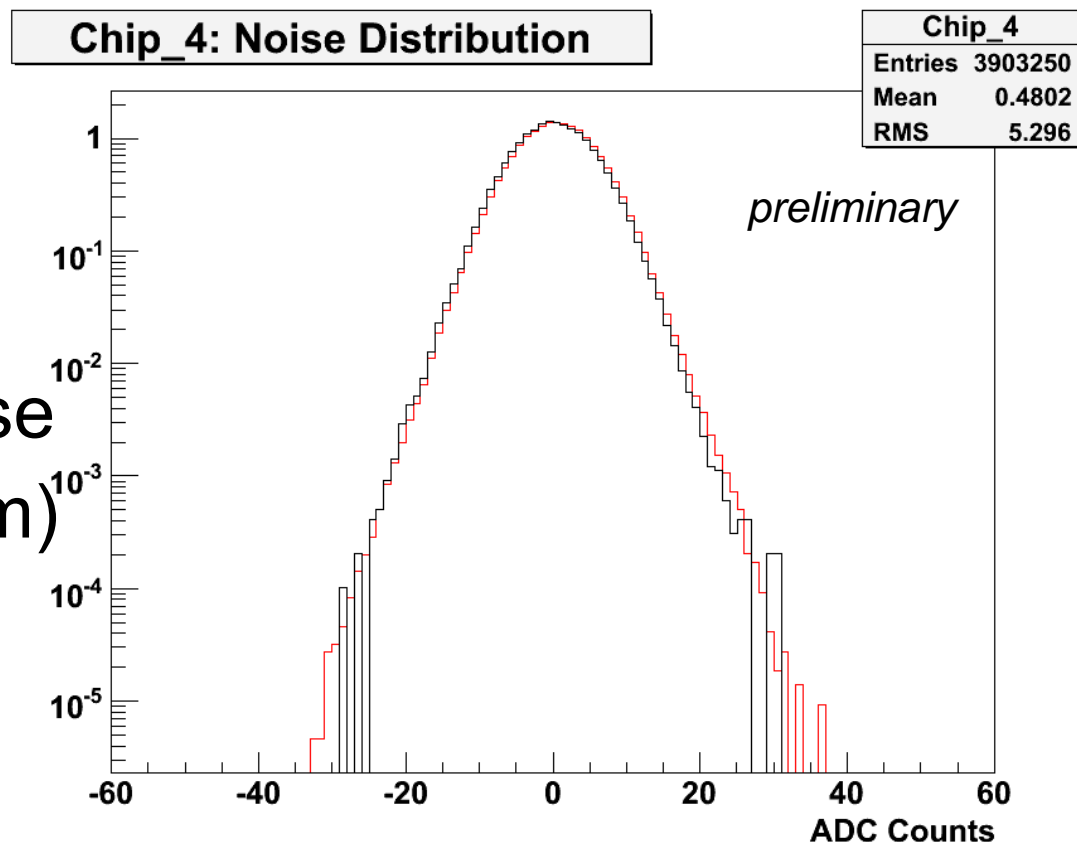
$(1/n)(dE/N_{lay}) [MIP]$



The special slab was placed in the ECAL in the centre of the shower

Two types of events:

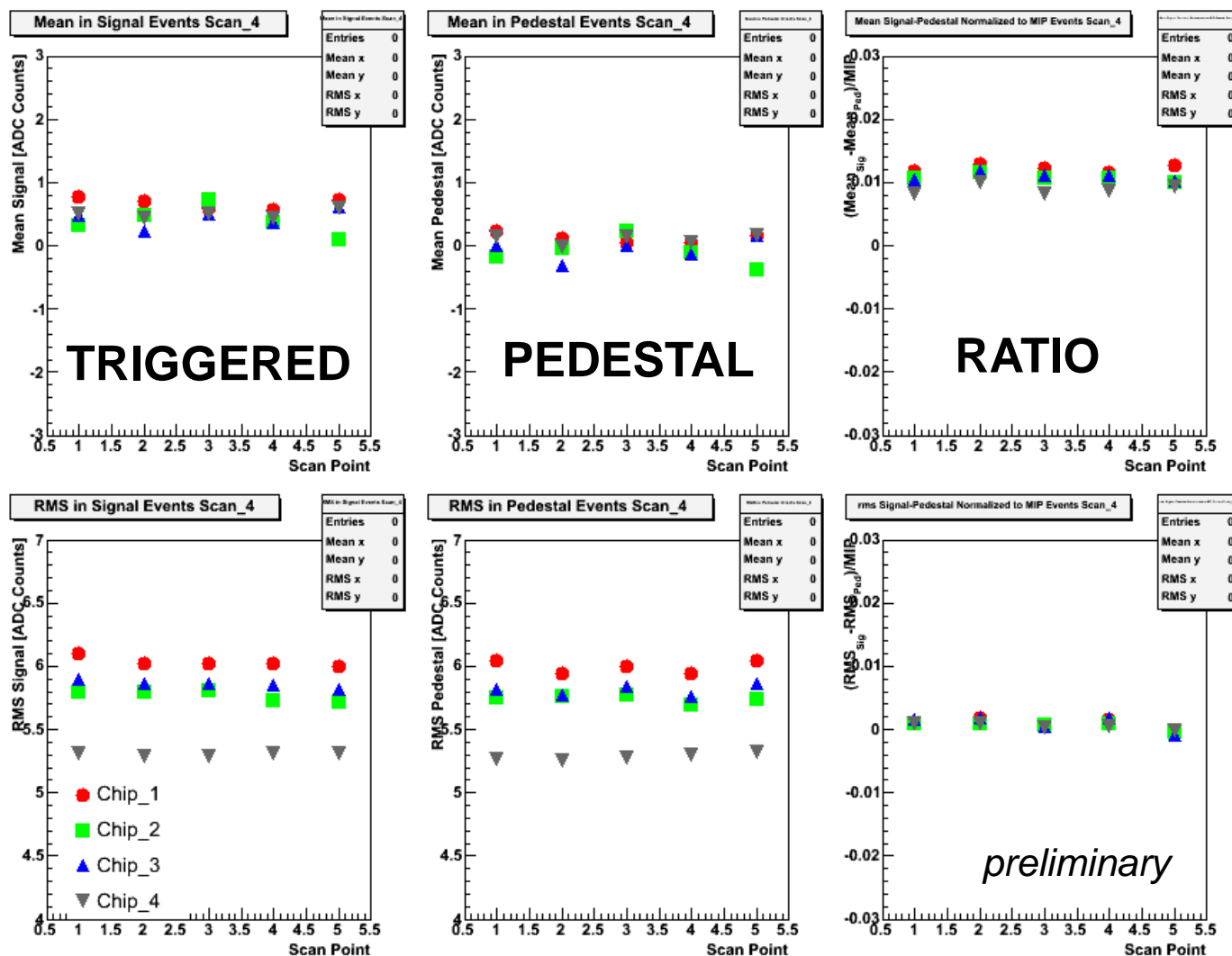
- triggered electrons
- pedestal events (noise run taken out of beam)



Tested global variables of noise spectra, mean and RMS



Results



Scan of chip 4

Mean

Global effect of
1% of MIP

Probably due to current
into the detector

RMS

Global effect of
<0.5% of MIP

No dependency on scan position visible

- The Si-W ECAL operated since 2006 in several testbeam with no major problems
- Response is stable with only 0.14% dead cells
- Linear response within 1%
- Energy resolution of $\left(\frac{16.6 \pm 0.1}{\sqrt{E(\text{GeV})}} \oplus (1.1 \pm 0.1) \right) \%$
- Next generation ECAL will need embedded electronics:
 - From irradiation test there is no evidence of shower induced signal